

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of )  
MURAKAMI et al. )  
Application Number: To be Assigned )  
Filed: Concurrently herewith )  
For: SEMICONDUCTOR DEVICE AND METHOD )  
OF MANUFACTURING THEREOF )  
Attorney Docket No. TSUT.0028 )

**Honorable Assistant Commissioner  
for Patents  
Washington, D.C. 20231**

**PRELIMINARY AMENDMENT**

Sir:

Prior to an examination on the merits, please amend the above identified application as follows: